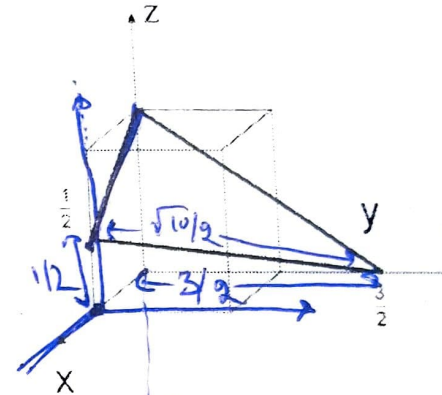


Date: 16-09-2017

Quiz-1 (Marks : 10) Time: 40 Min

Q1. Determine the Miller indices of the plane in the figure.

3



Q2. Draw the diamond structure for silicon and write down the number of atoms in one unit cell of Silicon. 2

Q3. How do you define direct and indirect semi-conductors? 2

Q4. Why do we need excess charge carriers and what are the ways to create these excess charge carriers? 2

Q5. What is the probability of being occupied by an electron of an energy state at the Fermi level? 1

$$\frac{3}{4} \times \frac{1}{4}$$

$$\frac{1}{4}$$

$$\frac{\sqrt{10}}{2}$$

$$0, 1, \frac{2}{3}, 1, 2$$

$$0.615$$

Date: 18-11-2017

Quiz- 2 (Marks : 10) Time: 40 Min

Q1. Draw The Energy Band Diagram in thermal equilibrium for metal semiconductor contacts for $\phi_m < \phi_s$, where type of semiconductor is of n type. [1]

Q2. Write a short-note on Metal-Semiconductor contacts. [2]

Q3. Give the energy band diagram of a MOS system. [1]

Q4. Discuss the surface inversion phenomenon in MOS structure and give its energy band diagram for the same. [3]

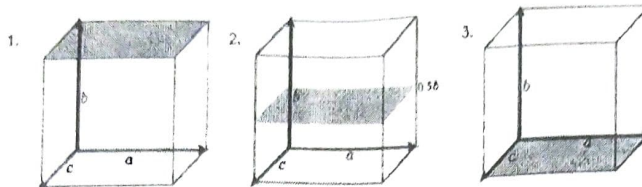
End-Sem Examination
Odd Semester - 2017-18
Semiconductor Devices and Circuits (SEMI)
B.Tech. (ECE) 2nd Year

Time: 3 Hrs

Total Marks: 50

All Questions are compulsory and Self-Explanatory.

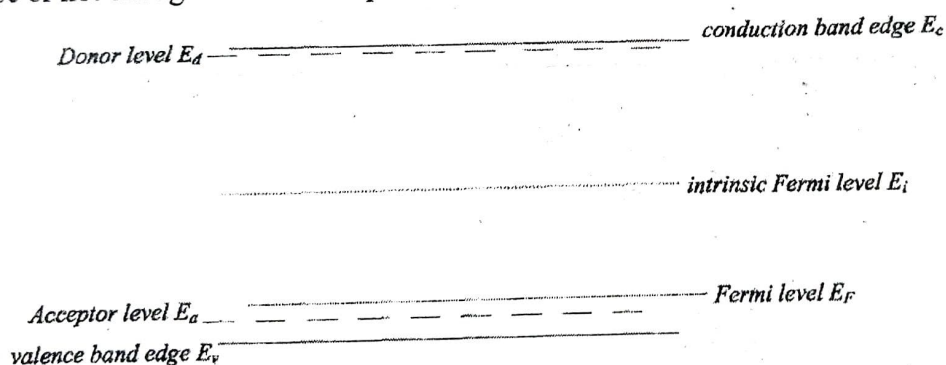
Q1. Discuss all the steps to determine the Miller Indices of a plane. Also, determine the miller indices for the following planes: [2 + 3]



Q2. A Si sample is doped with 10^{17} As atoms/cm³. What is the equilibrium hole concentration p_0 at 300 K? Where is E_F relative to E_i ? For your calculation you can use $n_i = 1.5 \times 10^{10}$ cm⁻³, $kT = 0.0259$ eV. [2]

Q3. Define the Hall Effect in n-type semiconductor. How do we identify the type of a material with the help of the Hall Effect? List down the 4 applications of Hall Effect. [3 + 2 + 2]

Q4. The equilibrium band diagram for a doped direct gap semiconductor is shown below. Is it n-type, p-type or not enough information provided? [1]



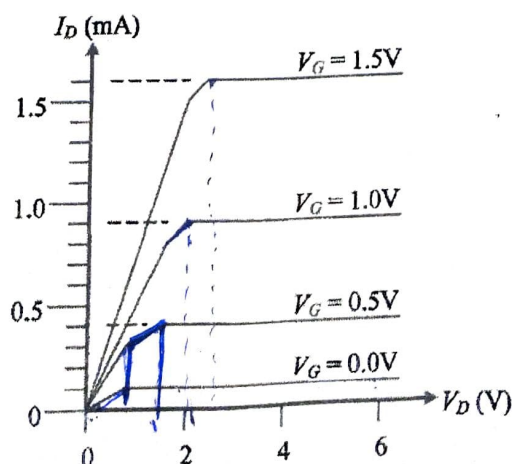
What if any of the following conditions by themselves could lead to the above band diagram?

Choose the correct answer from the following:

[1]

- Very high temperature
- Very high acceptor doping
- Very low acceptor doping

Q5. Consider the following MOSFET characteristic:

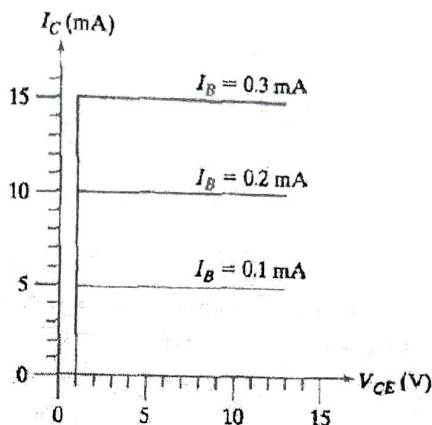
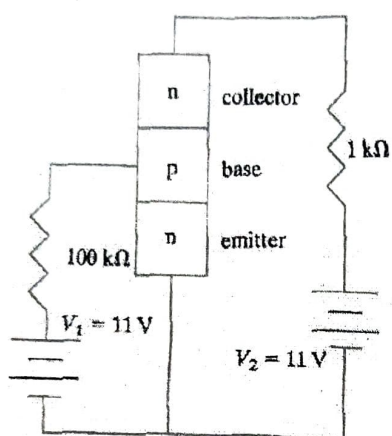


- Is this an n-channel or p-channel device? [1]
- Does this appear to be a long-channel or short-channel device? [1]
- What is the apparent threshold voltage V_T ? [1]
- Is this a depletion mode or enhancement mode MOSFET? [1]

Q6. (a) What is threshold voltage in MOSFET? Derive the *Threshold Voltage* equation for NMOS. Apply the substrate biasing V_{SB} to the derived equation and write down the final equation for the *Threshold Voltage*. [1 + 3 + 2]

(b) Calculate the threshold voltage V_{T0} at $V_{SB} = 0$, for a polysilicon gate n-channel MOS transistor, with the following parameters: substrate doping density $N_A = 10^{16} \text{ cm}^{-3}$, polysilicon gate doping density $N_D = 2 \times 10^{19} \text{ cm}^{-3}$, gate oxide thickness $t_{ox} = 50 \text{ nm}$ and oxide-interface fixed charge density $N_{ox} = 4 \times 10^{10} \text{ cm}^{-2}$. $kT/q = 0.026 \text{ eV}$, $n_i = 1.45 \times 10^{10} \text{ cm}^{-3}$, $\Phi_F(\text{gate}) = 0.55 \text{ V}$, $\epsilon_0 = 8.845 \times 10^{-14} \text{ Fcm}^{-1}$, $\epsilon_{si}/\epsilon_0 = 11.7$, $q = 1.6 \times 10^{-19} \text{ C}$ [4]

Q7. Consider the following bipolar junction transistor (BJT) circuit and somewhat idealized transistor characteristics where, in particular, the voltage drop across the forward biased base-emitter junction is assumed to be constant and equal to 1 V for simplicity.



- What is the (common-emitter) gain β ? [2]
- Draw the load line on the transistor characteristics. [2]
- What is the collector-emitter voltage drop in this circuit within half a volt? [2]
- If voltage V_1 could be changed, what value of V_1 would drive BJT in this circuit to the edge of saturation? [2]

Q8. Discuss the breakdown mechanisms in a lightly doped and heavily doped p-n junction under reverse biased condition. [2 + 2]

Q9. Write the short note on the followings:

(a) Channel Length Modulation

(b) Drain Induced Barrier Lowering

(c) Excess Charge Carriers in Semiconductors

(d) Continuity Equation

CODE:

S. No. 2949

The LNM Institute of Information Technology, Jaipur

(Deemed to be University)

Instruction to Candidate (for examination)

1. Immediately on receipt of the Test Booklet the candidate will fill in the required particulars on the cover page with Ball Point Pen only.
2. Candidates shall maintain perfect silence and attend to their Question Paper only. Any conversation or gesticulation or disturbance in the Examination Room / Hall shall be deemed as misbehaviour. If a candidate is found using unfair means or impersonating, it shall be treated as breach of code of conduct and the matter dealt with accordingly.
3. No candidate, without the special permission of the Invigilator concerned, will leave his/her seat or Examination Room until the full duration of the paper is over. Candidate should not leave the room / hall without handing over their Answer Sheets to the Invigilator on duty.
4. During the examination time, the invigilator will check ID Card of the candidate to satisfy himself / herself about the identity of each candidate. The invigilator will also put his/her signature in the place provided in the Answer Sheet.
5. The Candidate shall fill the number of supplementary sheets attached, on the front page of the main answer sheet.
6. **Bringing cell phones / communication devices in the examination hall is strictly prohibited. Exam conducting authority will not be responsible for the custody of such articles. However, use of scientific calculator is permitted.**

Name of the student: Vishakha PhamwamiRoll No. : 160EC126Name of Examination : MID-TERMSubject : SemiconductorDay & Date : Tuesday, 26/9/17

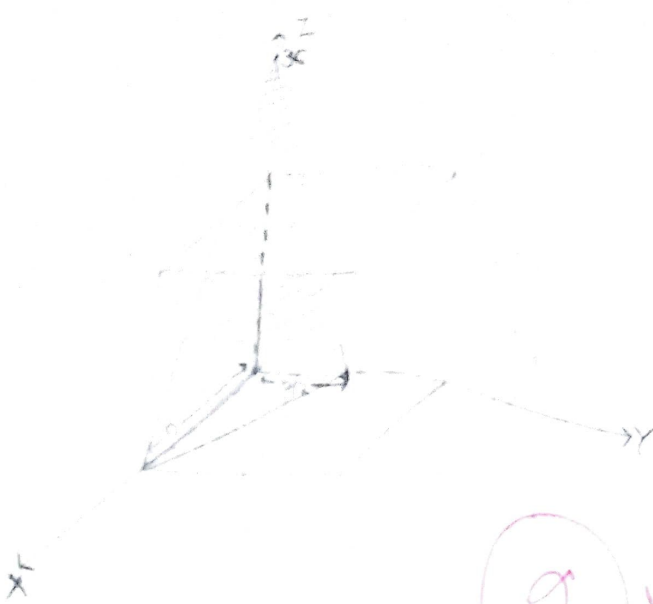
No. of Supplementary Sheets Attached:

[Signature]
Student's Signature

Invigilator's Signature

Question No.	Marks Obtained
1	4
2	3
3	4
4	3½
5	5
6	3
7	4
8	
9	
10	
Total Marks	26½ 30

Vishakha



(2)

x-intercept = a
y-intercept = b/a
z-intercept = 3c

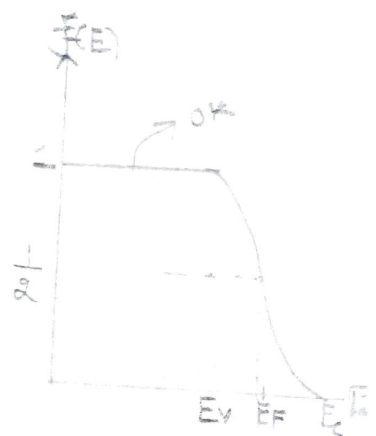
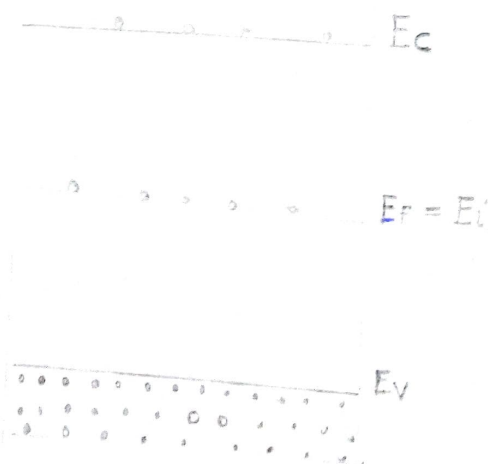
As it is a unit cell $a=1, b=1, c=1$

To obtain Miller indices Take reciprocal of intercepts
 $\left(1, \frac{1}{1/2}, \frac{1}{3}\right) = \left(1, 2, \frac{1}{3}\right) = (3, 6, 1)$

Miller indices of given plane are (h, k, l) i.e. $(3, 6, 1)$

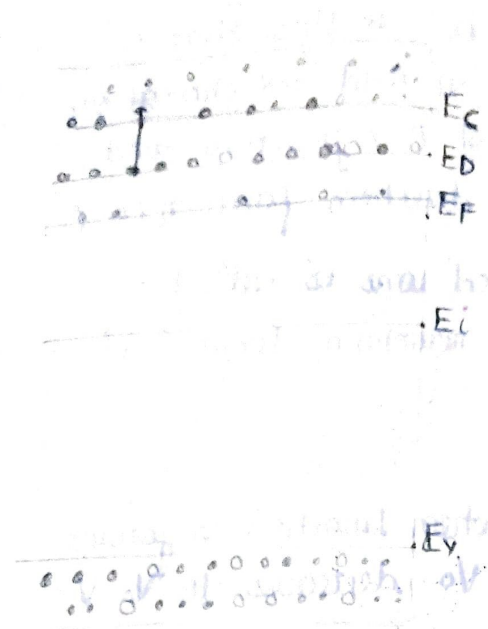
Q2

a) Intrinsic Semiconductor

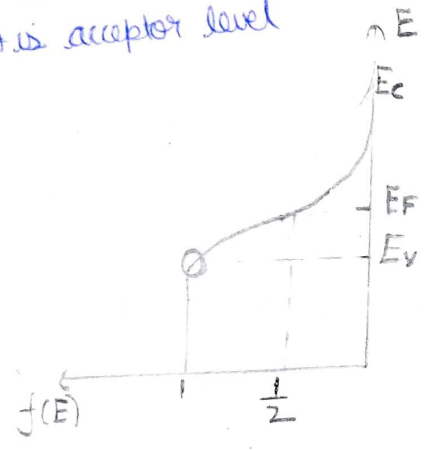


where E_c is Conduction band energy
 E_v is Valence band energy
 E_F Fermi level energy
 E_i is intrinsic Fermi level energy

(b) n-type semiconductor

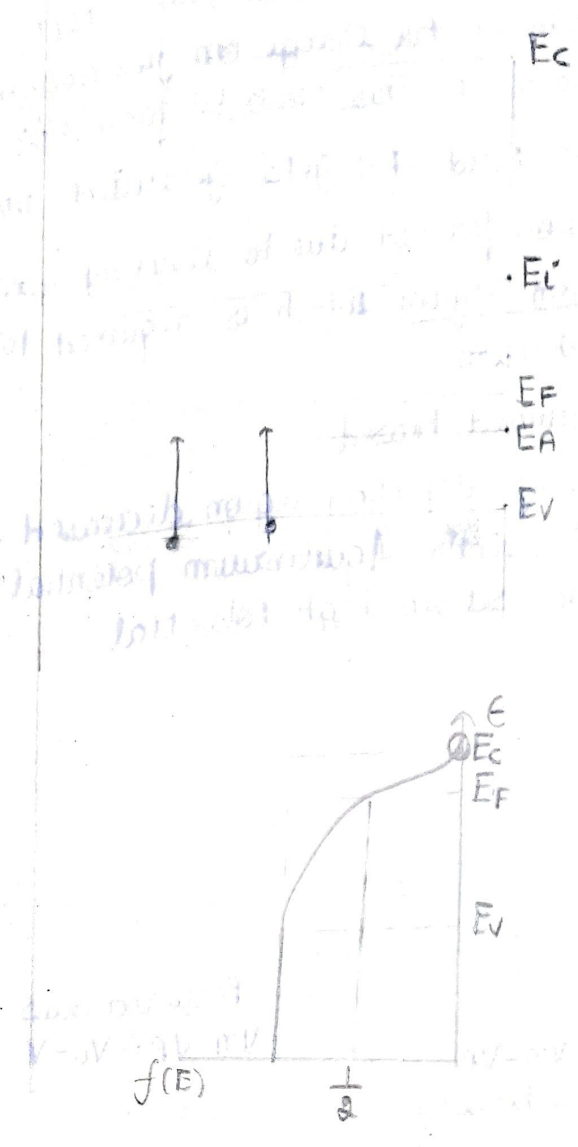


E_d is donor level
 E_a is acceptor level

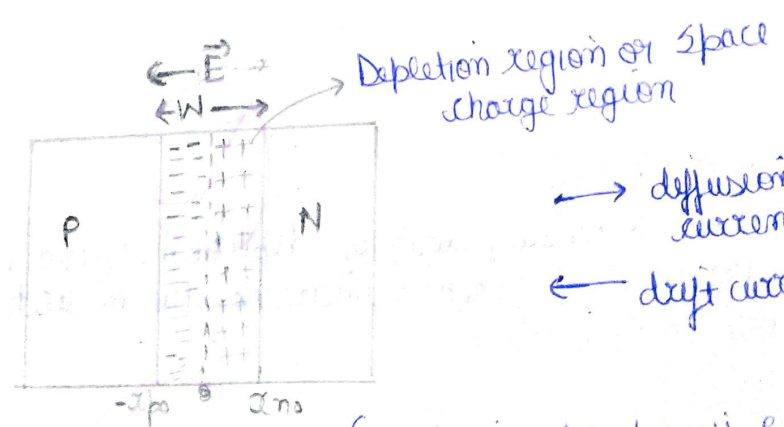


$f(E)$ is fermi Dirac distribution

3



Ques 3



1

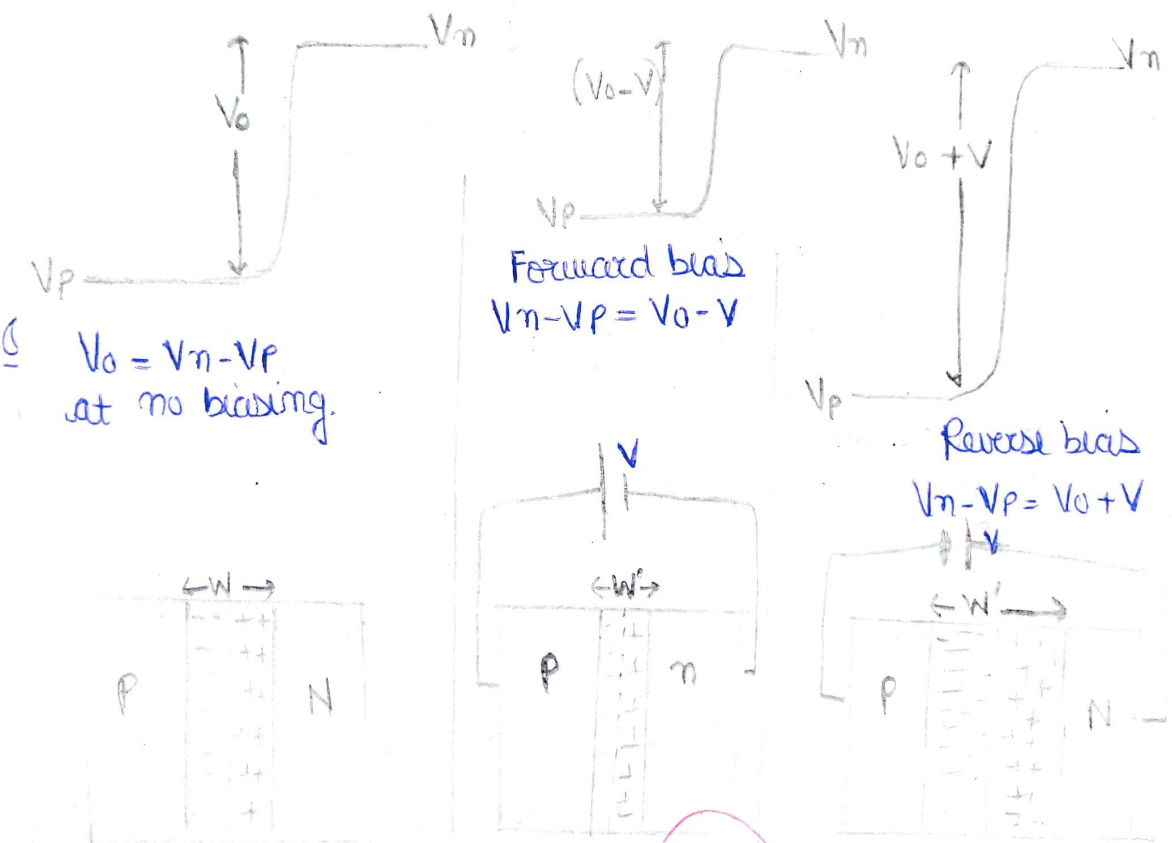
A P-N Junction is formed when two materials (one heavily doped with P-type material and other doped with n-type material) are brought close together. When p-type and n-type materials are brought close together, due to the concentration gradient, holes from the p-side move to the n-side and electrons from the n-side move to the p-side, leading to what is called the diffusion process.

holes move from p-to n side & leave behind uncompensated ions Na^+ and when e's move from n-to p side they leave behind uncompensated donor ions called Nd^+ . Due to this there is formation of +ve charge on junction of n and -ve charge on junction of p. This leads to formation of p-n junction and Electric Field (E) gets generated in direction from n to p.

The region formed due to uncompensated ions is called depletion region which is required to maintain Fermi level at equilibrium.

(a) Forward biased

Width of depletion region decreased when Junction is forward biased as the equilibrium potential V_0 decreases to $V_0 - V$ as p is set on high potential.



(b) Reverse biased

When Reverse biased, width of depletion region increases as Potential of junction increases due to which Electric Field increases

Ques 4 $N_a = 10^{18} \text{ cm}^{-3}$
 $N_d = 5 \times 10^{15} \text{ cm}^{-3}$

diameter of junction = $10 \mu\text{m}$

$I_{no}, \alpha_p, Q, \epsilon_0, T = 300 \text{ K}$

$$E_x = -\frac{q}{\epsilon} N_d \alpha_{no} = -\frac{q}{\epsilon} N_a \alpha_p$$

$$V_0 = \frac{KT}{q} \ln\left(\frac{N_a N_d}{n_i^2}\right) = 0.0259 \ln\left(\frac{10^{18} \times 5 \times 10^{15}}{2.25 \times 10^{20}}\right)$$

$$n_i^2 = 2.25 \times 10^{20}$$

$$V_0 = 0.0259 \left[\ln\left(\frac{5 \times 10^{13} \times 10^{13}}{2.25}\right) \right]$$

$$= 0.0259 \ln\left(\frac{500 \times 10^{13}}{2.25}\right)$$

$$= 0.0259 \left[\ln\left(\frac{500}{2.25}\right) + 13 \ln 10 \right]$$

$$V_0 = 0.0259 \left[\ln(2.22) + 13 \ln 10 \right] = 0.0259 \left[\ln(2.2) + 29.93 \right]$$

$$V_0 = 0.0259 (0.788 + 29.93)$$

$$V_0 = 0.0259 (30.718)$$

$$V_0 = 0.795 \text{ V}$$

$$V_0 = -\frac{1}{2} E_x W = \frac{1}{2} \frac{q}{\epsilon} N_d \alpha_{no} W$$

$$V_0 = \frac{1}{2} \frac{q}{\epsilon} N_d \left(\frac{N_a W}{N_a + N_d} \right) W$$

$$V_0 = \left(\frac{1}{2} \frac{q}{\epsilon} \frac{N_a N_d}{N_a + N_d} \right) W^2 = \left(\frac{1 \times 10^{-18} \times 5 \times 10^{15}}{2 \times 11.8 \times 8.845 \times 10^{-14} (N_a + N_d)} \right) W^2$$

$$V_0 = \left(\frac{0.0677 \times 10^{-5}}{8.845} \right) \frac{N_a N_d}{(N_a + N_d)} W^2$$

$$V_0 = \frac{(7.664 \times 10^{-8}) (5 \times 10^{33})}{(1000 + 5) 10^{15}} W^2$$

$$V_0 = \left(\frac{7.664}{1005} \right) \times 5 \times 10^{18} W^2$$

$$V_0 = (0.0381 \times 10^{18}) W^2$$

$$W = \sqrt{\frac{0.795 \times 10^{-18}}{0.0381}} = \sqrt{20.866} \times 10^{-9}$$

$$W = 4.56 \times 10^{-9} \text{ cm}$$

$$x_{n0} = \frac{N_A W}{N_A + N_D} = \frac{10^{18} 10^3 \times 4.56 \times 10^{-9}}{(1005) \times 10^{15}}$$

$$x_{n0} = 4.53 \times 10^{-9} \text{ cm}$$

$$x_{p0} = \frac{N_D W}{N_A + N_D} = \frac{5 \times 10^{15} \times 4.56 \times 10^{-9}}{(1005) \times 10^{15}}$$

$$x_{p0} = 0.0226 \times 10^{-9} \text{ cm}$$

$$Q_+ = A q N_D x_{n0}$$

$$= (\pi r^2) q N_D x_{n0}$$

$$= \pi \left(\frac{10 \mu\text{m}}{2} \right)^2 \times 1.6 \times 10^{-19} \times 5 \times 10^{15} \times 4.53 \times 10^{-9}$$

$$= \pi \times 25 \times 10^{-8} \times 1.6 \times 10^{-19} \times 5 \times 4.53 \times 10^6$$

$$= 3.14 \times 125 \times 1.6 \times 4.53 \times 10^{-21} \text{ C}$$

$$Q_+ = 2.844 \times 10^{-18} \text{ C}$$

312

Ques 5 $T = 300 \text{ K}$

$$N_D = 2.73 \times 10^{16} \text{ cm}^{-3}$$

(a) n_0 = Concentration of electron in conduction band

At equilibrium $n_0 \approx N_D$

$$\Rightarrow n_0 = 2.73 \times 10^{16} \text{ cm}^{-3}$$

$$n_0 p_0 = n_i^2 \quad ; \quad n_i \text{ is intrinsic carrier concentration}$$

p_0 = hole concentration in valence band

$$p_0 = \frac{n_i^2}{n_0} = \frac{(1.5 \times 10^{10})^2}{(2.73 \times 10^{16})} = \frac{2.25 \times 10^{20}}{2.73 \times 10^{16}}$$

$$(b) \quad p_0 = 0.824 \text{ cm}^{-3} \quad 0.824 \times 10^4 \text{ cm}^{-3}$$

(c) $N_A = 3.5 \times 10^{16} \text{ cm}^{-3}$

now $P_0 =$ hole concentration in valence band

$P_0 \approx N_A = 3.5 \times 10^{16} \text{ cm}^{-3}$

$n_0 = \frac{n_i^2}{N_A} = \frac{2.25 \times 10^{20}}{3.5 \times 10^{16}} = 0.642 \times 10^4 \text{ cm}^{-3}$

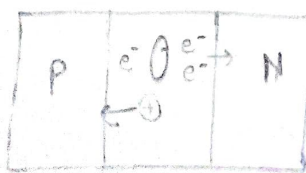
Total hole concentration now is $(8240 + 3.5 \times 10^{16}) \text{ cm}^{-3}$

Total electron concentration now is $(2.73 \times 10^{16} + 6420) \text{ cm}^{-3}$

Now hole and electron concentration are almost same but hole concentration is still greater than e^- concentration. Resulting material is P-type.

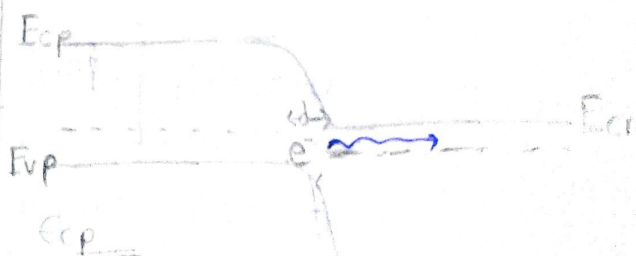
Ques 6 Avalanche Breakdown

- This occurs at higher reverse bias Voltage.
- This occurs when material is lightly doped and depletion width is large.
- In this ionization of host atom takes place when any carrier collides with atom and leads to formation of EHP.
- If generated carriers have sufficient kinetic energy then they further collide with other atoms and generate more carriers. generated hole is shifted towards P-side and e^- is moved towards n-side.



Zener Breakdown

- This occurs at comparatively lower reverse bias voltage.
- In this tunneling effect of electron takes place leading to generation of tunneling current.
- It occurs when material is highly doped and depletion width is small so that e^- can easily go inside tunnel being created.
- In this two bands cross each other. empty conduction band of n-side is opposite to filled band i.e. valence band of P-side.



Sample A

$$N_d = 10^6 \text{ cm}^{-3}$$

$$\mu_n = 1000 \text{ cm}^2/\text{V}$$

$$\mu_p = 300 \text{ cm}^2/\text{V}$$

$$N_c = 2.78 \times 10^{19}$$

$$kT = 0.0259 \text{ eV}$$

$$V_0 = \frac{kT}{q} \ln \frac{N_a N_d}{n_i^2}$$

$$N_d = N_c e^{-(E_c - E_F)/kT}$$

$$\frac{N_d}{N_c} = e^{-(E_c - E_F)/kT}$$

$$\frac{-(E_c - E_F)}{kT} = \ln \left(\frac{N_d}{N_c} \right)$$

$$\frac{+E_F}{0.0259} = \ln \left(\frac{10^6}{2.78 \times 10^{19}} \right)$$

$$E_F = 0.0259 \ln \left(\frac{1}{2.78} \times 10^{-3} \right)$$

$$= 0.0259 \left[\ln \left(\frac{100}{278} \right) - 3 \ln(10) \right]$$

$$\left(\ln(0.35) - 3(2.303) \right)$$

$$0.0259 (-1.049 - 6.909)$$

$$0.0259 (-8.318)$$

$$E_F = -0.215 \text{ eV}$$

2

Sample B

$$-(E_c - E_F)/kT$$

$$N_d = N_c e^{-(E_c - E_F)/kT}$$

$$\ln \left(\frac{N_d}{N_c} \right) = \frac{E_F}{kT}$$

$$E_F = 0.0259 \left[\ln \left(\frac{10^{18}}{2.78 \times 10^{19}} \right) \right]$$

$$0.0259 \left[\ln \left(\frac{100}{278} \right) - 2.303 \right]$$

$$0.0259 (-1.049 - 2.303)$$

$$E_F = 0.0259 (-3.352)$$

$$E_F = -0.08 \text{ eV}$$

2